

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE STATEMENT

APPLICANT: Takeshi Nogami, et al. **ATTY DOCKET NO.:** 9792909-5802
SERIAL NO.: not yet assigned **GROUP ART UNIT:** not yet assigned
DATE FILED: February 10, 2004 **EXAMINER:** not yet assigned
INVENTION: "SEMICONDUCTOR MANUFACTURING APPARATUS AND
METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES"

which is a Divisional of the following copending U.S. Application:

APPLICANT: Takeshi Nogami, et al **ATTY DOCKET NO.:** 9792909-5219
SERIAL NO.: 10/149858 **GROUP ART UNIT:** 2818
DATE FILED: October 7, 2002 **EXAMINER:** R. Berry
INVENTION: "SEMICONDUCTOR MANUFACTURING APPARATUS AND
METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES"

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

SIR:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

I. **SUBMITTED UNITED STATES PATENT REFERENCES**

<u>Reference</u>	<u>Patent Number</u>	<u>Inventor</u>	<u>Issue Date</u>
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II. SUBMITTED FOREIGN PATENT REFERENCES

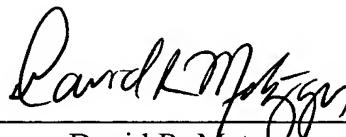
<u>Reference</u>	<u>Patent Number</u>	<u>Country</u>	<u>Date of Publication</u>
AH	JP51 1326	Japan	January 8, 1976
AI	JP02 217498	Japan	August 30, 1990

III. OTHER ITEMS OF INFORMATION

IV. EXPLANATION OF RELEVANCE

The above references were made of record in parent application U.S. Serial No. 10/149,858 filed October 7, 2002, based on PCT application No. PCT/JP01/08981.

Submitted by,

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37 CFR 1.501 INFORMATION DISCLOSURE STATEMENT IN A PATENT (use several sheets if necessary)	Docket No. 09792909-5802	Serial No.
	Applicants: Takeshi Nogami, et al.	
	Filing Date February 10, 2004	Group Art Unit

U.S. PATENT DOCUMENTS

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AH	JP51 1326	1-8-76	Japan				
	AI	JP02 217498	8-30-90	Japan				
	AJ							
	AK							
	AL							
	AM							
	AN							
	AQ							
	AP							
	AQ							
	AR							
	AS							
	AT							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AU	
AV	
AW	
AX	
AY	
AZ	

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.